

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Akihisa HONGO et al.

Serial No. 10/735,771

Filed December 16, 2003



: Confirmation No. 4044

: Attorney Docket No. 2003_1822A

: Group Art Unit 1792

: Examiner Sylvia R. MacArthur

SUBSTRATE PROCESSING APPARATUS
AND SUBSTRATE PROCESSING METHOD

Mail Stop: AMENDMENT

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975**

Sir:

Petition hereby is made for a one month extension of time to respond to the communication of
January 11, 2008.

The fee of \$120.00 is

(X) submitted herewith.

() to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is
enclosed.

Respectfully submitted,

Akihisa HONGO et al.

By

A handwritten signature in black ink, appearing to read "Aldo A. D'Ottavio".

Aldo A. D'Ottavio
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Agent for Applicants

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April 30, 2008